

## Application of High-Temperature Extrinsic Fabry-Perot Interferometer Strain Sensor

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May 1, 2008

**Cleared for public release** 

## **Outline**

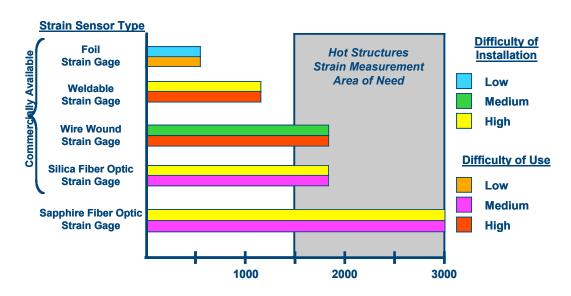
- Background
- Objective
- Sensor
- Attachment Techniques
  - Sensor Construction
  - Thermal Spray Process
- Evaluation / Characterization
- Future Fiber Optic Testing





# **Background**

## **Sensor Development Motivation**



#### Lack of Capability

- TPS and hot structures are utilizing advanced materials that operate at temperatures that exceed our ability to measure structural performance
- Robust strain sensors that operate accurately and reliably beyond 1800°F are needed but do not exist

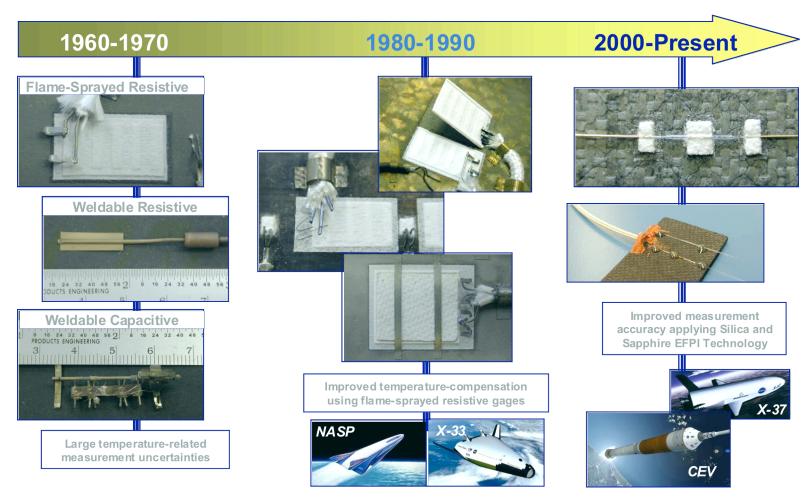
#### Implication

- Hinders ability to validate analysis and modeling techniques
- Hinders ability to optimization structural designs



# **Background**

#### **Strain Sensor Maturation**



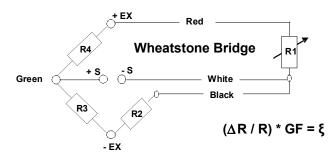


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# **Background**

## **Electrical Resistive Strain Gage**

#### **High-Temp Quarter-Bridge Strain Gage**



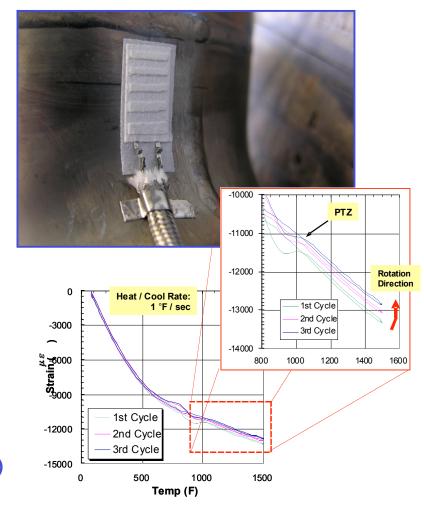
#### Pro's

- Sturdy / rugged thermal sprayed installation and spot-welded leadwire stakedown
- Available high sample rate DAS, usually AC coupled to negate large ξapp

#### Con's

- Large magnitude ξapp primarily due to wire TCR, slope rotates cycle-to-cycle
- Sensitivity (GF): Function of temperature

$$\xi app = [TCR_{gage} / GF_{set} + (\alpha_{sub} - \alpha_{gage})] * (\Delta T)$$



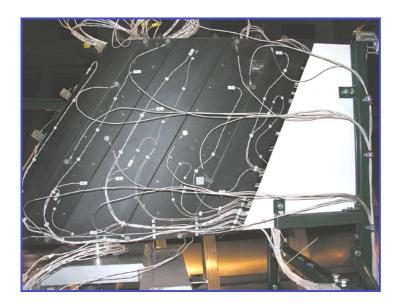


# **Objective**

# Provide strain data for validating finite element models and thermal-structural analyses

- Develop sensor attachment techniques for relevant structural materials
- Perform laboratory tests to characterize sensor and generate corrections to apply to indicated strains
- Instrument large scale hot-structures test articles

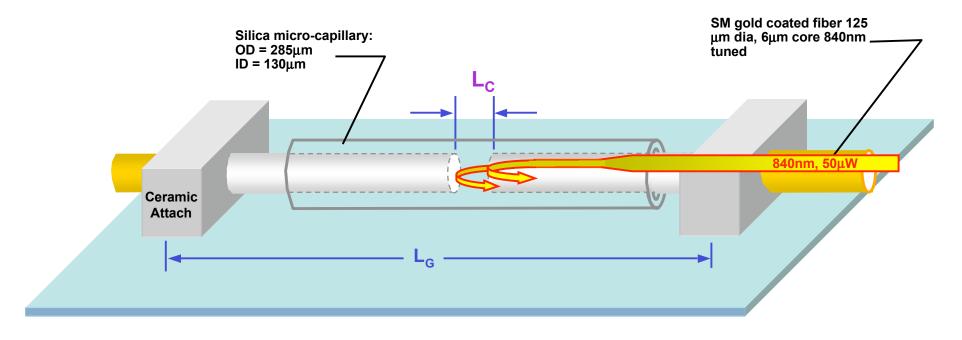




## **EFPI Strain Sensor**

#### **Static Measurement**

## **Extrinsic Fabry-Perot Interferometer (EFPI)**



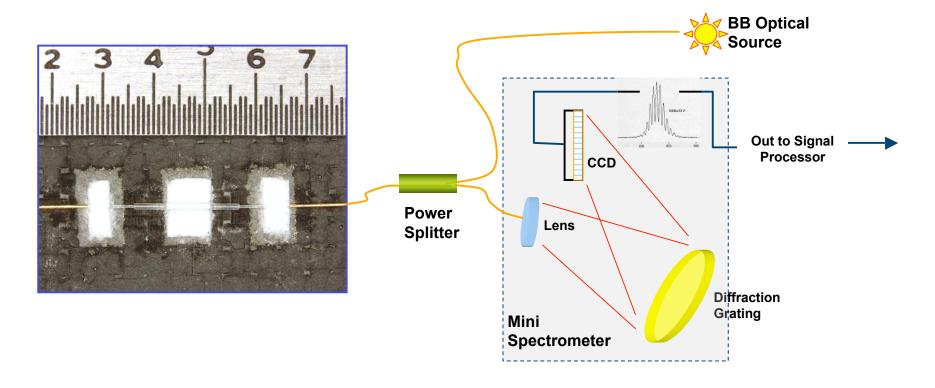
Strain =  $\Delta L_C$  /  $L_G$  (initial), where sensitivity =  $L_G$  Apparent Strain ( $\xi$ app) = ( $\alpha_{sub}$  -  $\alpha_{fiber}$ ) \*  $\Delta T$ 



## **EFPI Strain Sensor**

#### **Static Measurement**

## **Single Mode Interferometer Signal Conditioning**





# Develop sensor attachment techniques for relevant structural materials

- Derive surface prep and optimal plasma spray parameters for applicable substrate
  - powder media / type, power level, traverse rate, and spraying distance
- Or, optimize / select cement that best fits application
- Improve methods of handling and protecting fragile sensor during harsh installation processes

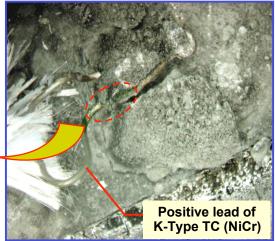


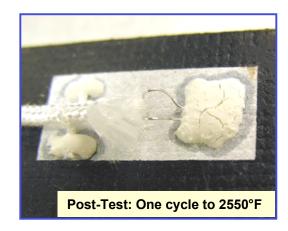
## **Thermal Spray vs. Cement**

# Thermal sprayed attachments are preferred even though cements are simpler to apply

- Tests indicate increased gage-to-gage scatter on first cycle
- Cements are often corrosive to TC or strain gage alloys
  - Si / Pt, NaF / Fe-Cr-Al alloys, alkali silicate / Cr
- Cements are more prone to bond failure due to shrinkage and cracking caused when binders dissipate









## **Thermal Spray Equipment**

#### **Thermal Spray Room**

- 80KW Plasma System
- Rokide Flame-Spray System
- Powder Spray System
- Grit-Blast Cabinet
- Micro-Blast System
- Water Curtain Spray Booth





## **Thermal Spray**

#### **Arc-plasma sprayed base coat**

- Metallic Substrates: Used to transition high expansion substrate metal with low expansion sensor attachment material (Al<sub>2</sub>O<sub>3</sub>)
- CMC Substrates (inert testing): High melting-point ductile transitional metals (i.e. Ta, TiO<sub>2</sub>, & Mo) more conducive for attachment to smooth surfaces like SiC

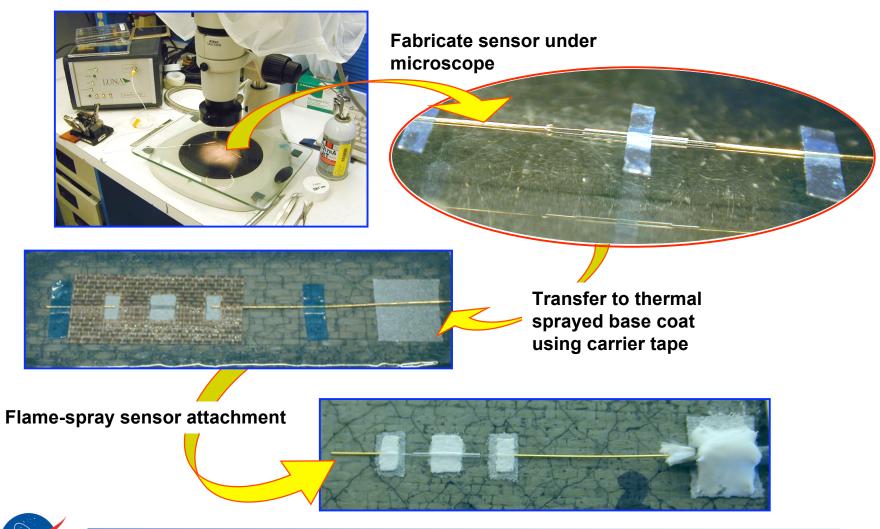


#### **Rokide flame-sprayed sensor attachment**

- Applies a less dense form of alumina than plasma spraying
- Electrically insulates (encapsulate) wire resistive strain gages

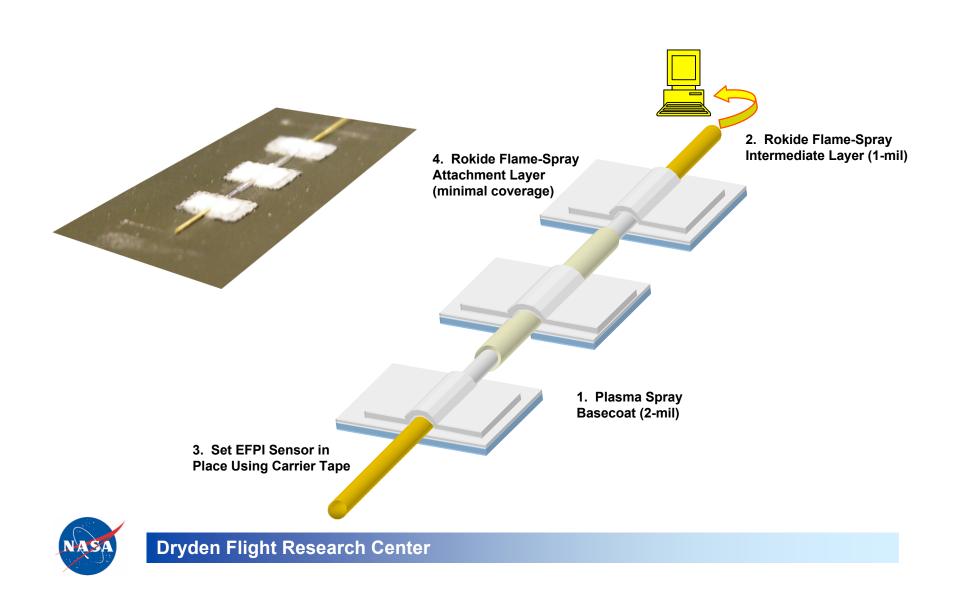


## **Fiber Optic EFPI Installation**

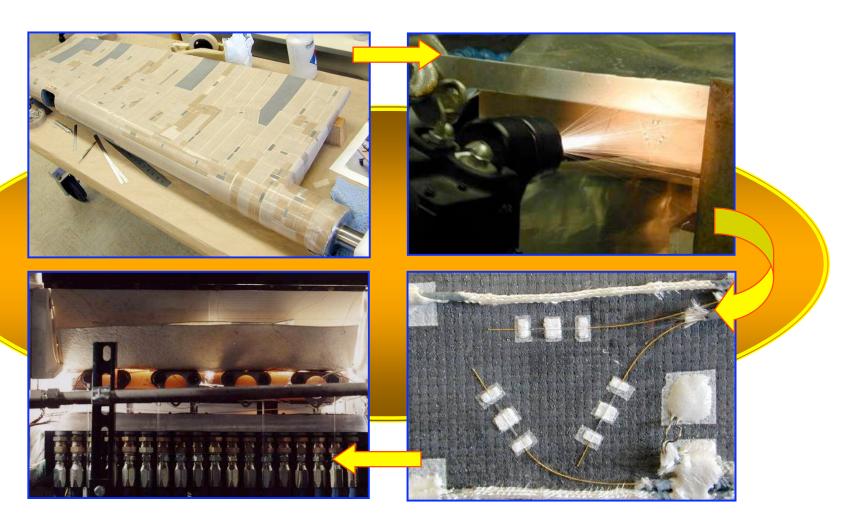


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## **Fiber Optic EFPI Installation**



**Large-Scale Structures** 



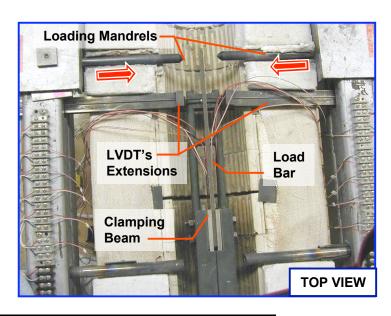


## Validate and characterize strain measurement

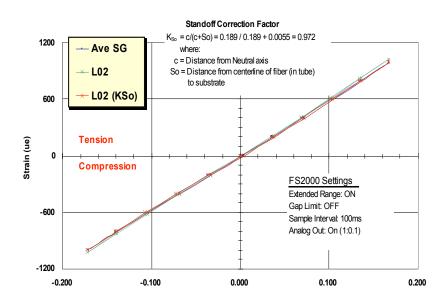
- Base-line / characterize high-temperature strain sensors on monolithic Inconel specimens
  - Known material spec's isolate substrate from inherent sensor traits prior to testing on more complex composites
- Evaluate / characterize sensitivity (GF) of strain sensors on ceramic composite substrates using laboratory combined thermal / mechanical load fixture
- Generate apparent strain curves for corrections on relevant ceramic composite substrates

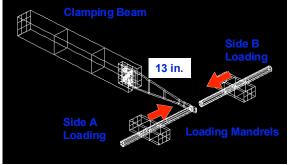


### **Combined Thermal / Mechanical Loading (Obsolete)**



#### **EFPI Combined Loading on IN625**





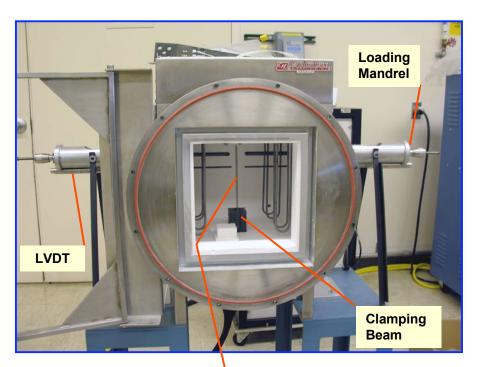
#### Thermal / Mechanical Cantilever Beam Testing of EFPI's

- Excellent correlation with SG to 550°F (3%)
- Very little change to 1200°F
- Slight drop in output slope above 1200°F
- Maximum gap readability uncertain at upper range temperatures on high expansion material



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## **Combined Thermal / Mechanical Loading (Current)**



# Furnace / cantilever beam loading system for sensitivity testing

- Air or inert (3000°F max)
- 12-in<sup>3</sup> inner furnace with Molydisilicide elements
- Micrometer / mandrel side loading
- LVDT displacement measurements
- POCO Graphite hardware for inert environment testing of ceramic composites
- IN625 hardware for metallic testing in air
- Sapphire viewing windows





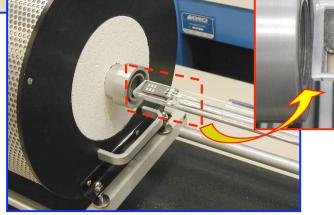
## **Dilatometer Testing**



## **Sensor Characterization**Air or inert (3000°F max)

- Evaluate bond integrity
- Generate ξapp correction curves
- Evaluate sensitivity and accuracy
- Evaluate sensor-to-sensor scatter, repeatability, hysteresis, and drift

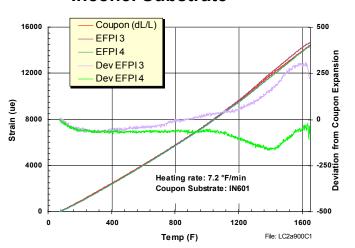
4 EFPI's on C-C



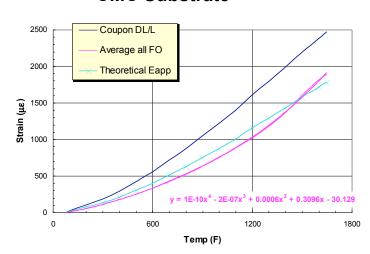


### **EFPI Apparent Strain**

#### **Inconel Substrate**



#### **CMC Substrate**



 $\xi_{app}$  Correction: The removal of inherent sensor traits and substrate expansion from indicated strain to acquire true applied strains or thermal stresses

$$\xi_{\text{true}} = \xi_{\text{indicated}} - \xi_{\text{app}}$$
, where  $\xi_{\text{app}} = (\alpha_{\text{sub}} - \alpha_{\text{fiber}}) * \Delta T$ 

- Inconel (LH chart): Expansion ratio between IN and Si so large no sensor correction required (output primarily substrate expansion, CTE \* ΔT)
- CMC (RH chart): Small CTE ratio between C-SiC and Si requires a correction for the growth in fiber (lessening cavity gap) verses the expansion of the substrate
- Graphs demonstrate how well actual ξapp curves followed theoretical



# **Future Fiber Optic Testing**

- Test single-mode silica EFPI's in combined thermal / mechanical load fixture on C-C and C-SiC substrates
- Develop Sapphire strain sensor (multi-mode)
  - Keep precise parallel gap faces aligned throughout process
    - Develop precision transfer method (i.e. temporary alignment fixture)
  - Test in laboratory thermal / mechanical loads fixture to > 2500°F
- Test and evaluate high-temperature fiber Bragg Gratings for use as strain and temperature sensors
- Attach and evaluate high-temperature heat flux gage
- Evaluate weldable (shim) EFPI strain sensor on Inconel

